



Selected Papers from ICMEAS 2017

Guest Editors:

Prof. Dr. Ruxu Du

Department of Mechanical &
Automation Engineering, The
Chinese University of Hong Kong,
Hong Kong, China

Prof. Dr. Kyle Jiang

Department of Mechanical
Engineering, University of
Birmingham, Birmingham, UK

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Message from the Guest Editors

Dear Colleagues,

This Special Issue is a compilation of the top ten papers selected from the papers presented at the 2017 International Conference on Mechanical Engineering and Automation Science (<http://www.icmeas.org/>), held in Birmingham, 13–15 October, 2017. This Special Issue is aimed at exhibiting the new development in the research of micromachines and/or micro-components of machines. The covered topics include design, modeling and simulation, material, prototyping, experiment testing, as well as automatic control. A number of practical examples are included.

Prof. Dr. Ruxu Du

Prof. Dr. Kyle Jiang

Guest Editors





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Editor-in-Chief

Prof. Dr. Ai-Qun Liu

1. Department of Electrical and Electronic Engineering, The Hong Kong Polytechnic University, Hong Kong, China
2. School of Electrical and Electronic Engineering, Nanyang Technological University, Singapore 639798, Singapore

Message from the Editor-in-Chief

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Micromachines Editorial Office
MDPI, Grosspeteranlage 5
4052 Basel, Switzerland

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